ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18 Stylesheet Version v18.0

> Title of Invention

Surface Treatment Using Iodine Plasma To Improve Metal **Deposition**

Application Number:

10/821751

Confirmation Number:

1874

First Named Applicant:

Jeremie Dalton

Attorney Docket Number: 101.114

Art Unit:

2812

Search string:

(6605549 or 6638859 or 6413864 or 6468907

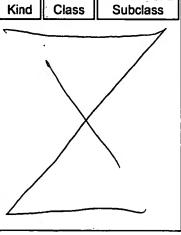
or 6593236 or 6613695 or 6605735 or 6284652

or 6074945).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	
VY	1	6605549	2003-08-12	Leu	
एप	2	6638859	2003-10-28	Sneh	
VЧ	3	6413864	2002-07-02	Pyo	
Va	4	6468907	2002-10-22	Pyo	
Va	5	6593236	2003-07-15	Pyo	
14	6	6613695	2003-09-02	Pomarede	
74	7	6605735	2003-08-12	Kawano	
VY	8	6284652	2001-09-04	Charneski	
VY	9	6074945	2000-06-13	Vaartstra '	



Signature

Examiner Name	Date		
V. Yushan	05/31/05		

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PTO/SB/08b(05-03) Approved for use through 04/30/2003. OMB 0851-0031

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Substitute for form 1449A/PTO Complete if Known **Application Number** 10/821,751 INFORMATION DISCLOSURE Filing Date 8 April 2004 STATEMENT BY APPLICANT First Named Inventor Jeremie James Dalton **Group Art Unit** 2812 (use as many sheets as necessary) **Examiner Name** Unknown Sheet of 1 Attorney Docket Number 101.114

		OTHER PRIOR ART NON PATENT LITERATURE DOCUMENTS			
Examiner Cite Include name of the author (in CAPITAL LETTERS) the item (book, magazine, journal, serial, symposium		Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	sium, catalog, etc.), date, page(s), volume-issue T ²		
V4	1	KWON ET AL., "Enhancement of Iodine Adsorption Using I₂ Plasma for Seedless Catalyst-Enhanced CVD of Copper", Electrochemical and Solid State Letters, 6, (8) C109-C111 (2003), The Electrochemical Society, Inc.			
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Examiner Signature V. Yuy Vov	Date Considered	05/31/05
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